



Receipt  
FW IMAGE

In re application of : **Mail Stop: ISSUE FEE**  
Tomohiro OKUMURA et al. : **Confirmation No. 3756**  
Serial No. 09/511,398 : [Group Art Unit 1762  
Filed February 23, 2000 : Examiner M. Padgett]  
PLASMA PROCESSING METHOD : **THE COMMISSIONER IS AUTHORIZED**  
AND APPARATUS : **TO CHARGE A DEFICIENCY IN THE**  
**FEEES FOR THIS APPLICATION TO DEPOSIT**  
**ACCOUNT NO. 23-0975**

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

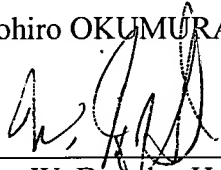
A corrected filing receipt is requested in the above-referenced case. The corrected filing receipt dated June 5, 2000, a copy of which is enclosed, should be corrected as follows:

Please correct the name of the fourth listed inventor from "Izura Matsuda" to --Izuru Matsuda.

Please expedite issuance of the corrected filing receipt.

Respectfully submitted,

Tomohiro OKUMURA et al.

By   
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August 18, 2004

## CORRECTED FILING RECEIPT



\*OC000000005155276\*

UNITED STATES DEPARTMENT OF COMMERCE  
Patent and Trademark OfficeAddress: ASSISTANT SECRETARY AND  
COMMISSIONER OF PATENT AND TRADEMARKS  
Washington, D.C. 20231

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/511,398	02/23/2000	1762	1918	00177/530809	18	55	9

Wenderoth Lind & Ponack LLP  
2033 K Street NW Suite 800  
Washington, DC 20006

Date Mailed: 06/05/2000

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Continuing Data as Claimed by Applicant

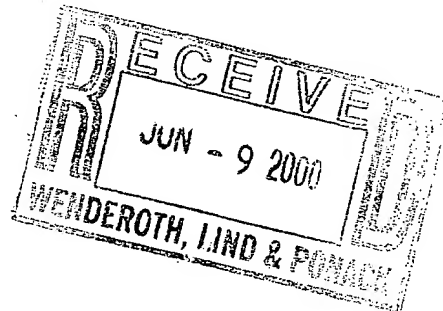
## Foreign Applications

JAPAN 11-044359 02/23/1999  
 JAPAN 11-046245 02/24/1999

If Required, Foreign Filing License Granted 05/02/2000

## Title

Plasma processing method and apparatus



## Preliminary Class

427